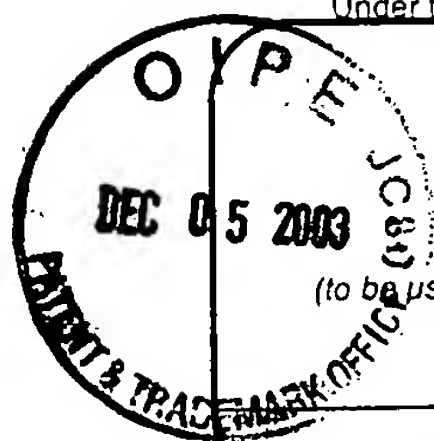


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Application Number

10/655,699

Filing Date

September 5, 2003

First Named Inventor

Garo J. Derderian

Art Unit

Unknown

Examiner Name

Unknown

Attorney Docket Number

MI22-2307

## ENCLOSURES (Check all that apply)

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| <input type="checkbox"/> Fee Transmittal Form<br><input type="checkbox"/> Fee Attached<br><input type="checkbox"/> Amendment/Reply<br><input type="checkbox"/> After Final<br><input type="checkbox"/> Affidavits/declaration(s)<br><input type="checkbox"/> Extension of Time Request<br><input type="checkbox"/> Express Abandonment Request<br><input checked="" type="checkbox"/> Information Disclosure Statement<br><input type="checkbox"/> Certified Copy of Priority Document(s)<br><input type="checkbox"/> Response to Missing Parts/ Incomplete Application<br><input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53 | <input type="checkbox"/> Drawing(s)<br><input type="checkbox"/> Licensing-related Papers<br><input type="checkbox"/> Petition<br><input type="checkbox"/> Petition to Convert to a Provisional Application<br><input type="checkbox"/> Power of Attorney, Revocation<br><input type="checkbox"/> Change of Correspondence Address<br><input type="checkbox"/> Terminal Disclaimer<br><input type="checkbox"/> Request for Refund<br><input type="checkbox"/> CD, Number of CD(s) _____ | <input type="checkbox"/> After Allowance communication to Technology Center (TC)<br><input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences<br><input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)<br><input type="checkbox"/> Proprietary Information<br><input type="checkbox"/> Status Letter<br><input checked="" type="checkbox"/> Other Enclosure(s) (please identify below):<br>Return Receipt Postcard<br>PTO-1449 and cited references |
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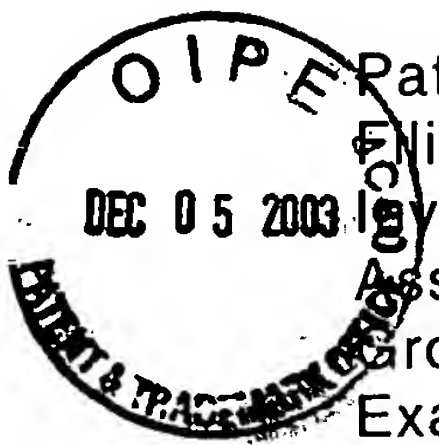
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EL 979950772

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Patent Application Serial No. .... 10/655,699  
Filing Date ..... September 5, 2003  
Inventorship ..... Garo J. Derderian et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... Unknown  
Examiner ..... Unknown  
Attorney's Docket No. .... MI22-2307  
Title: Methods of Depositing a Silicon Dioxide Comprising Layer in the  
Fabrication of Integrated Circuitry, Methods of Forming Trench Isolation in  
the Fabrication of Integrated Circuitry

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**


References - See Attached Form PTO-1449

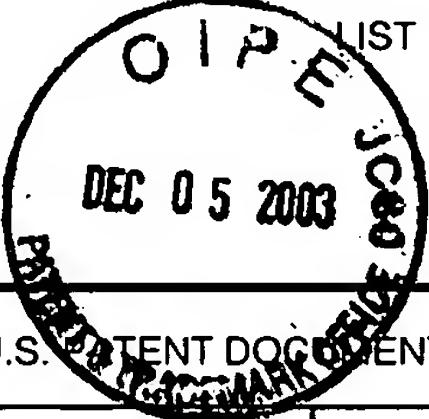
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are attached hereto. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 12-5-03

By:   
Mark S. Matkin  
Reg. No. 32,268

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<div style="text-align: center;">  <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p> </div>				APPLICANT: Garo J. Derderian et al.			
				FILING DATE September 5, 2003	GROUP Unknown		
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes      No
	AJ						
	AK						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM		Hausmann et al., "Catalytic vapor deposition of highly conformal silica nanolaminates", Department of				
			Chemistry and Chemical Biology, Harvard University, May 14, 2002, pp. 1-13.				
	AN						
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